## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	application of:	)
Kenichi NAGAYAMA )		Confirmation No.: 7384
Applic	eation No.: 10/586,584	) Group Art Unit: 2826
Filed:	February 28, 2008	) Examiner: Tan N. Tran
For:	SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING SAME	) ) )

Commissioner for Patents U.S. Patent and Trademark Office Customer Window, Mail Stop Amendment Alexandria, VA 22314

Sir:

## AMENDMENT

In response to the Office Action dated February 18, 2009, the period for response to which runs through May 18, 2009, please amend the above-identified application as follows: